

Receipt date: 07/15/2010

10539549 - GAU: 1714

OK TO ENTER: /G.N.R./ (07/29/2010)

/G. Nagesh Rao/ (07/29/2010)

Reply under 37 C.F.R. 1.116
Expedited Procedure
Technology Center 1714

Confirmation No. 7976

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	MAGNEE, et al.	Examiner:	Rao, G.
Serial No.:	10/539,549	Group Art Unit:	1714
Filed:	June 16, 2005	Docket No.:	BE020044US1 (NXPS.420PA)
Title:	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE		

**REQUEST TO WITHDRAW FINALITY,
AMENDMENT, AND RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Customer No. 65913

Dear Sir:

In response to the Final Office Action dated May 17, 2010, please reconsider the application in view of the following amendments and remarks.

A complete listing of the claims, to include any amendments presented therein, begins on page 2 of this paper and Remarks follow.

Authorization is provided to charge/credit **Deposit Account 50-4019**
(BE020044US1) any requisite fees/overages to enter this paper.